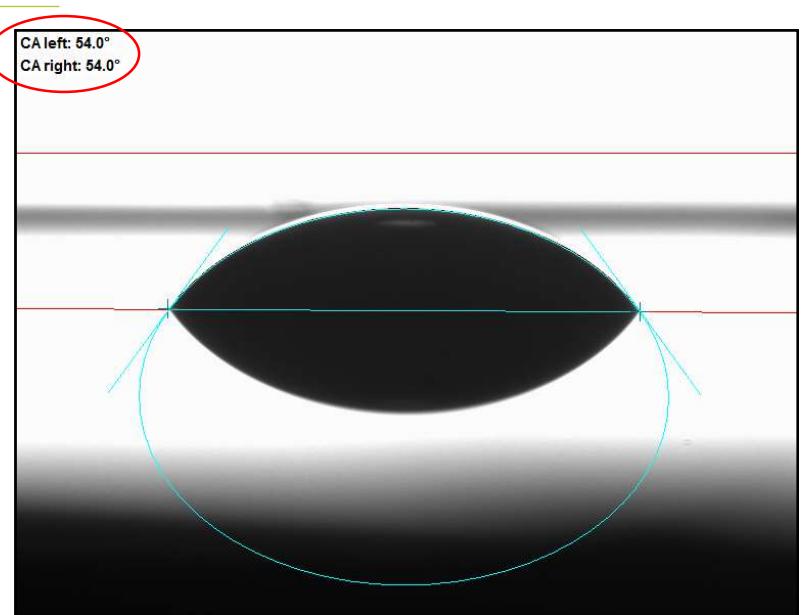
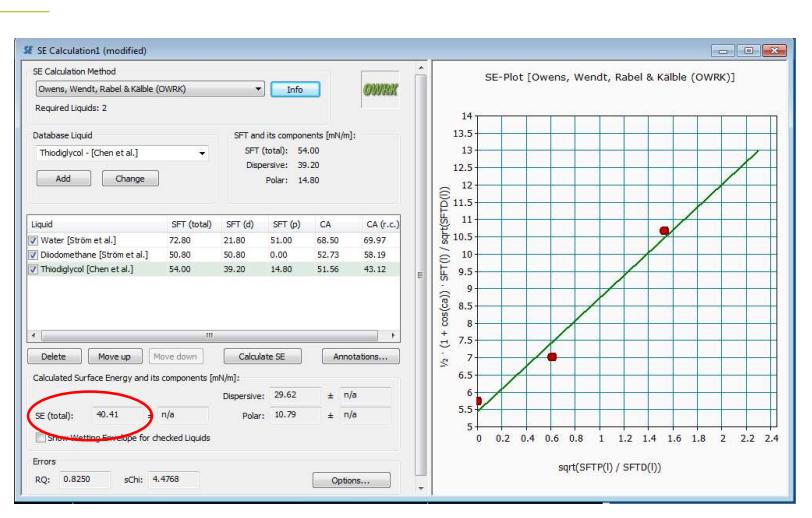


Wettability Characterization

In the MicroFabSpace facilities there is a contact angle measurement equipment, useful for the characterization of surface-liquid interactions at the macro-scale. One can measure contact angle of different liquids and determine the surface free energy of different surfaces under investigation.



Contact angle measurement of diiodomethane on silicon wafer.



Surface free energy calculation of bare silicon wafer.